



PATENT APPLICATION
Do. No. 8371-127

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Apostolos VOUTSAS and Yukihiro NAKATA

Serial No. 09/945,063

Examiner: George R. Fourson III

Filed: August 31, 2001

Group Art Unit: 2823

For: **METHOD OF FORMING MULTI-LAYERS FOR A THIN FILM
TRANSISTOR (TFT) AND THE DEVICE FORMED THEREBY**

Box Non-Fee Amendment
Assistant Commissioner for Patents
Washington, D.C. 20231


RECEIVED
DEC 11 2002
TECHNOLOGY CENTER 2800

TRANSMITTAL LETTER

Responsive to the Office Action dated October 31, 2002, enclosed is an amendment in the above-identified application.

[X] Any deficiency or overpayment should be charged or credited to deposit account number 13-1703.

Respectfully submitted,


Hosoon Lee
Limited Recognition Under 37 CFR § 10.9(b)

MARGER, JOHNSON & McCOLLOM, P.C.
1030 S.W. Morrison Street
Portland, Oregon 97205
(503) 222-3613

I HEREBY CERTIFY THAT THIS COR-
RESPONDENCE IS BEING DEPOSITED
WITH THE UNITED STATES POSTAL
SERVICE AS FIRST CLASS MAIL IN AN
ENVELOPE ADDRESSED TO:
THE COMMISSIONER OF PATENTS AND
TRADEMARKS, WASHINGTON D.C. 20231
X ASSISTANT COMMISSIONER FOR
PATENTS, WASHINGTON D.C. 20231
THE ASSISTANT COMMISSIONER FOR
TRADEMARKS, 2500 CRYSTAL DRIVE
ALEXANDRIA, VA 22304-3513

ON Dec. 2, 2002

